

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Hajime SHIRAKAWA et al.

Serial No.: 10/807,052

Filed: March 22, 2004

Confirmation No.: 2685

Date: January 19, 2007

Group Art Unit: 1765

Examiner: Anita Karen Alanko

For: SUBSTRATE TREATING METHOD AND APPARATUS

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VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**RESPONSE TO FINAL REJECTION**

Sir:

This is a response to the final Office Action mailed October 19, 2006 in the above-identified application. Reconsideration of the application is respectfully requested.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

**CONTINGENT EXTENSION REQUEST**

If this communication is filed after the shortened statutory time period had elapsed and no separate Petition is enclosed, the Commissioner of Patents and Trademarks is petitioned, under 37 C.F.R. § 1.136(a), to extend the time for filing a response to the outstanding Office Action by the number of months which will avoid abandonment under 37 C.F.R. § 1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.